

FIG. 1A

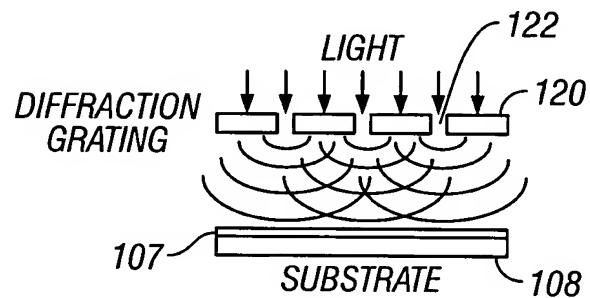


FIG. 1B

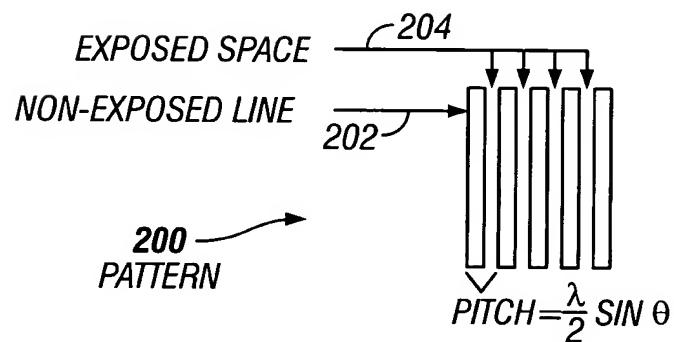


FIG. 2

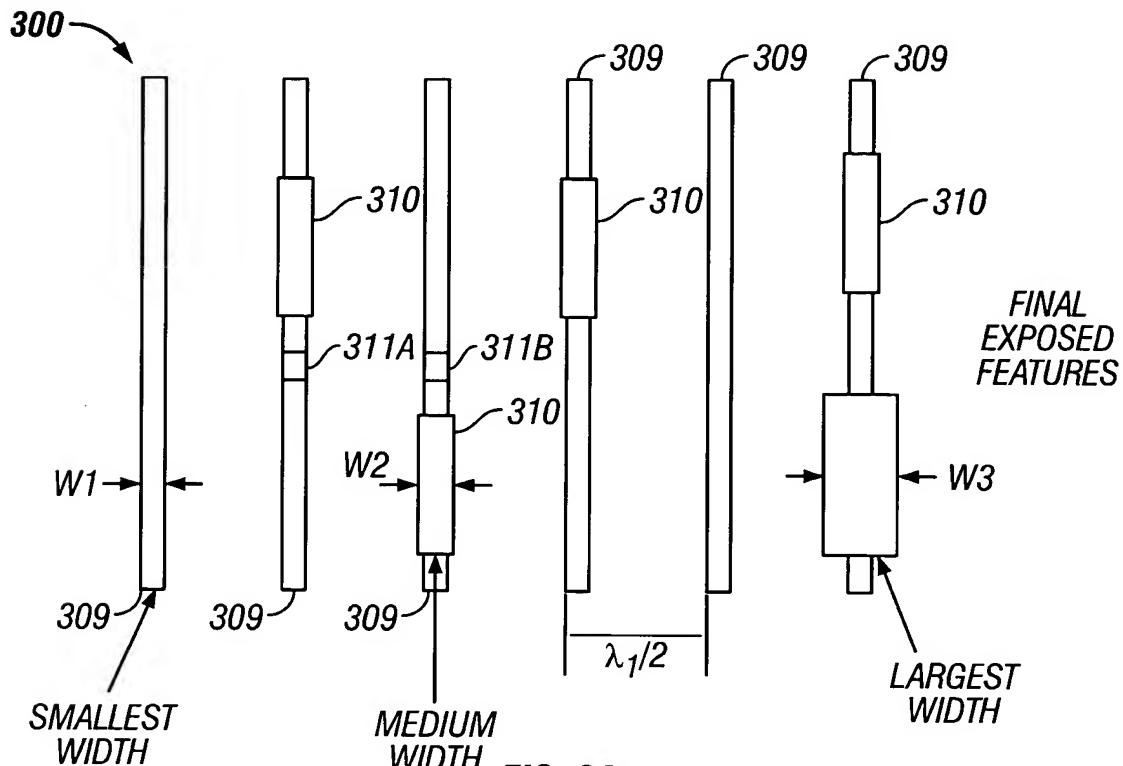


FIG. 3A

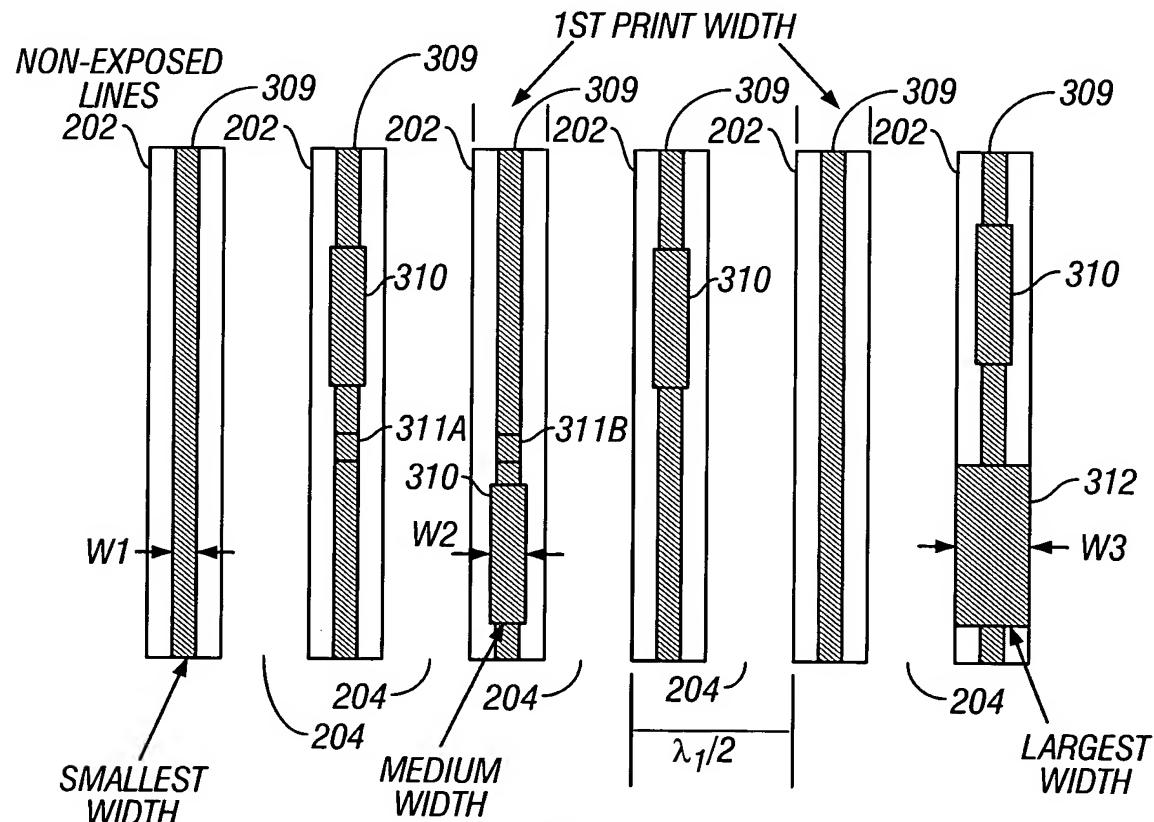


FIG. 3B

Applicant: Yan Borodovsky
COMPOSITE OPTICAL LITHOGRAPHY METHOD FOR
PATTERNING LINES OF UNEQUAL WIDTH

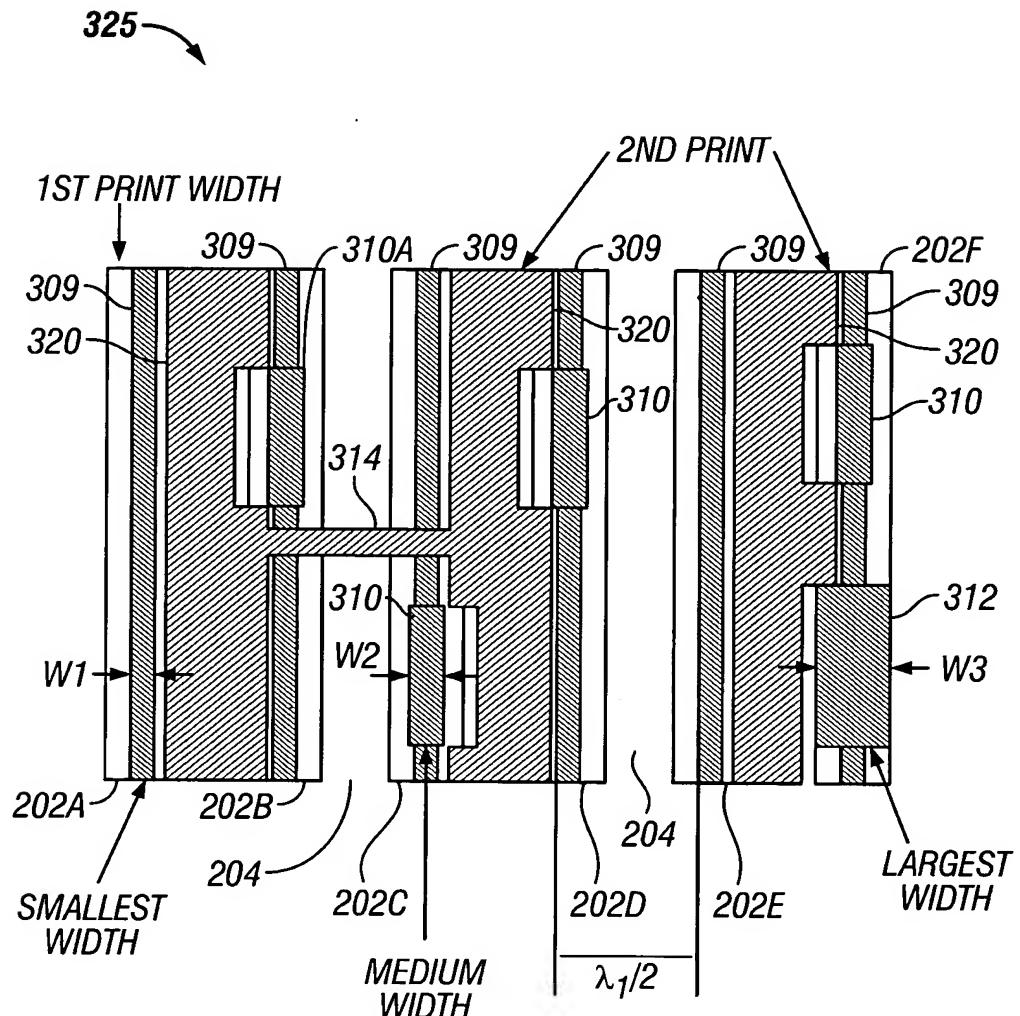
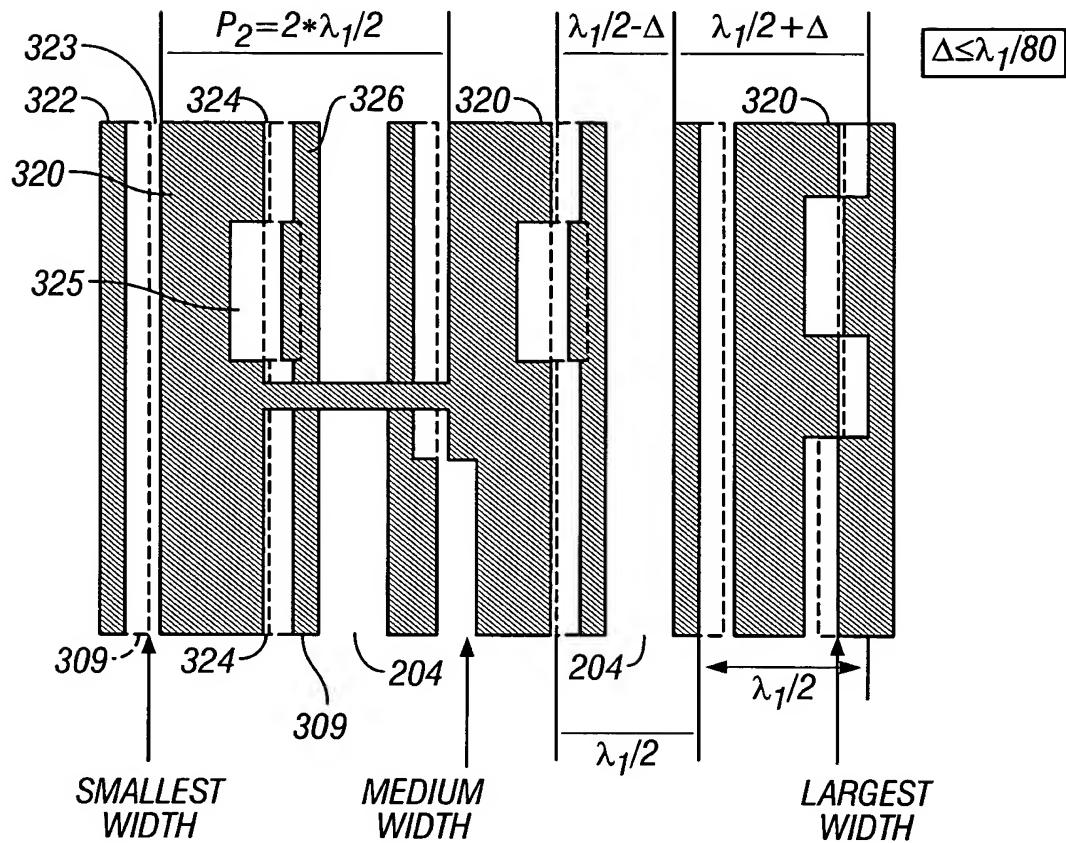


FIG. 3C

**FIG. 3D**

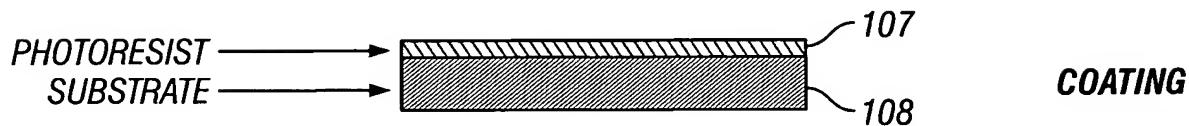


FIG. 4A

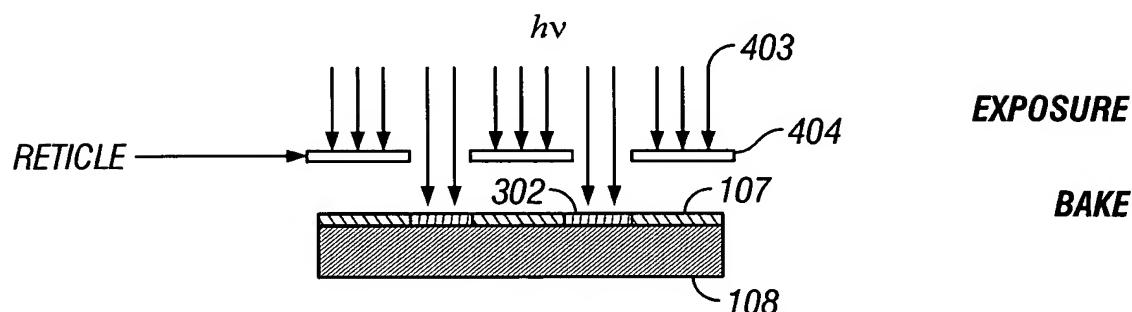


FIG. 4B

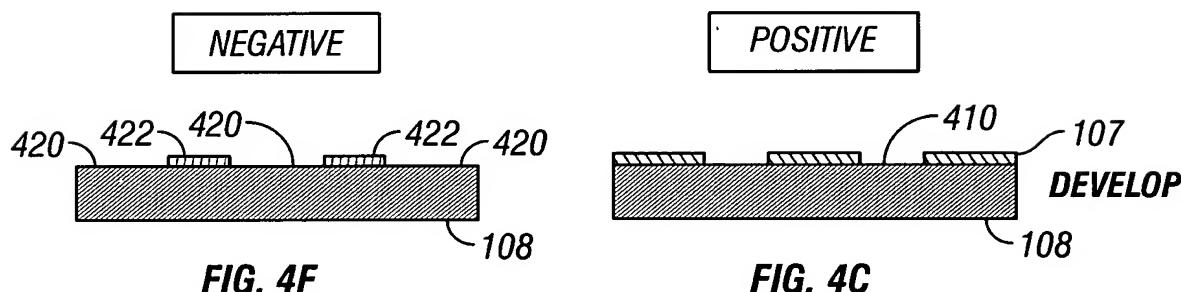


FIG. 4F

FIG. 4C

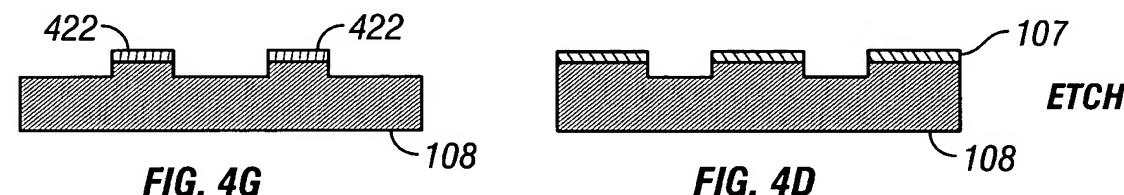


FIG. 4G

FIG. 4D



FIG. 4H

FIG. 4E

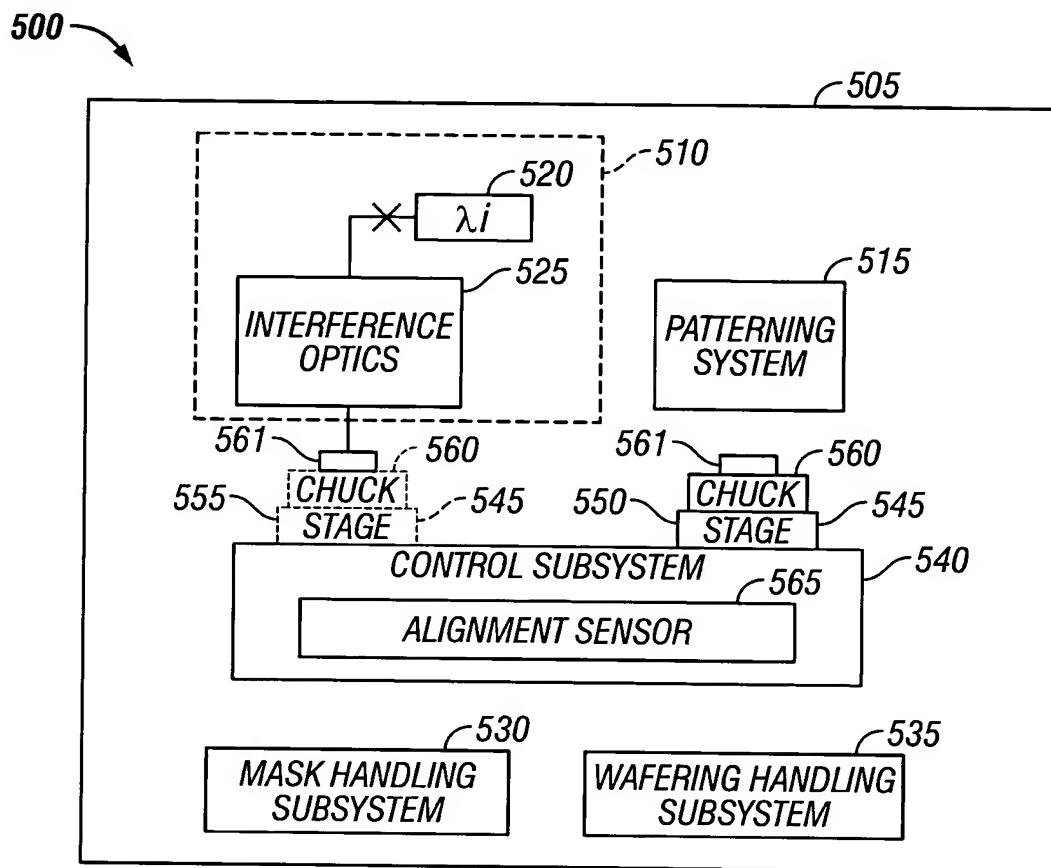


FIG. 5

515

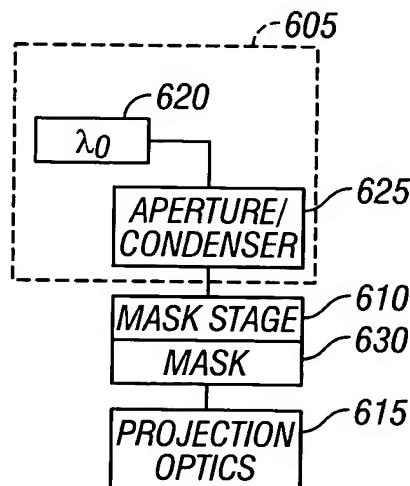


FIG. 6

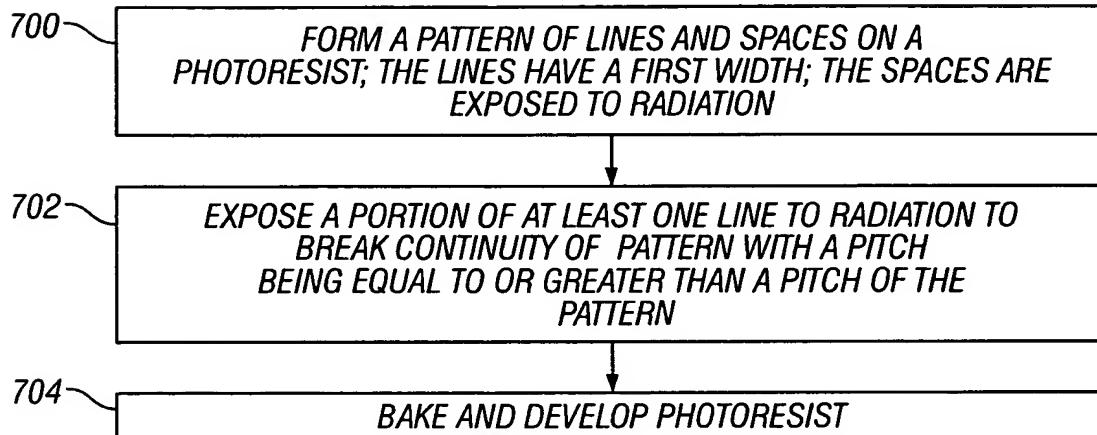


FIG. 7

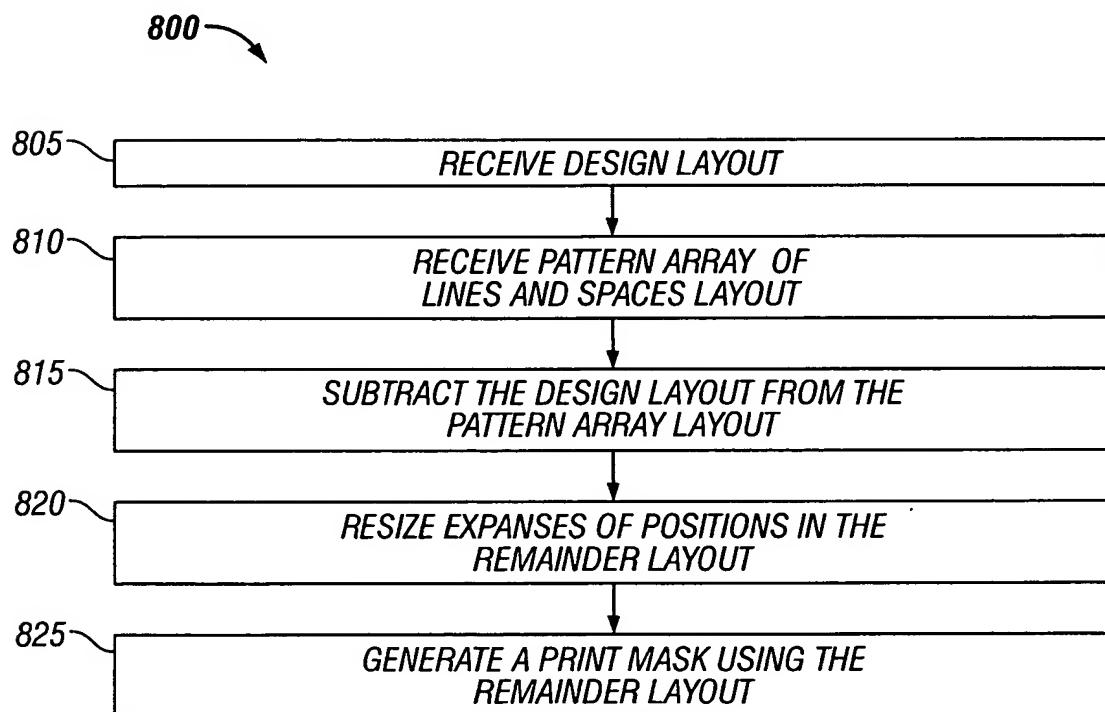


FIG. 8

900

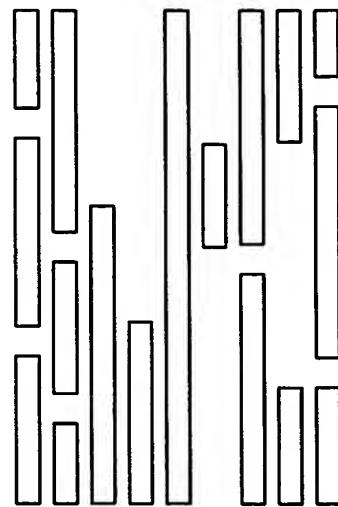


FIG. 9

1000

1100

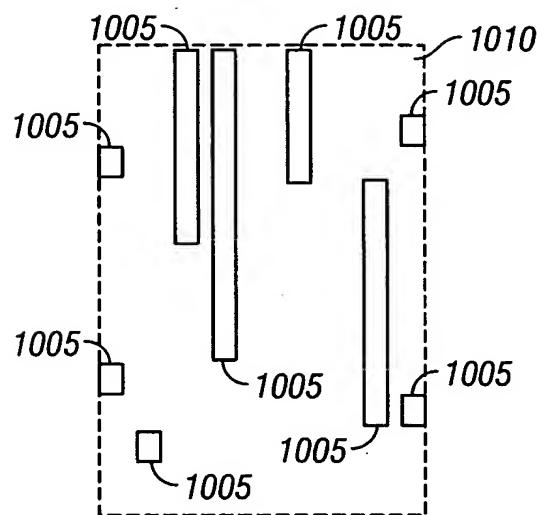


FIG. 10

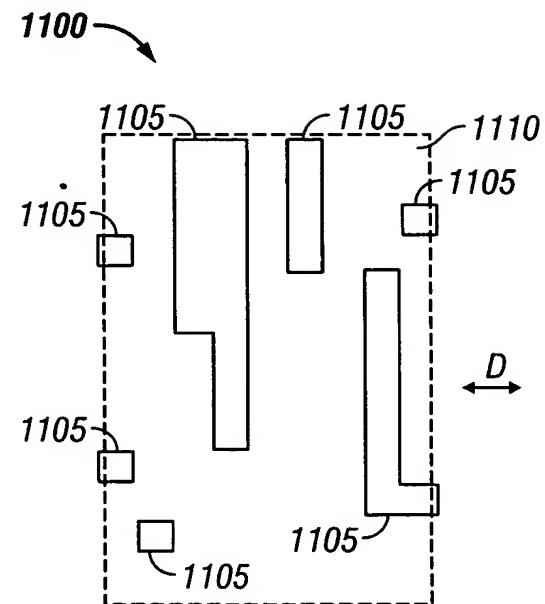


FIG. 11